



Doc. No.: 49657-961

#14/Ext. of Time (3)
1:16:03
C. Moore
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kenji ITOGA, et al.

Serial No.: 09/769,490

Group Art Unit: 2882

Filed: January 26, 2001

Examiner: C. Kao

For: X-RAY EXPOSURE APPARATUS, X-RAY EXPOSURE METHOD, X-RAY MASK, X-RAY MIRROR, SYNCHROTRON RADIATION APPARATUS, SYNCHROTRON RADIATION METHOD AND SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, DC 20231

Sir:

It is respectfully requested that the time for response to the Office Action dated May 23, 2002, now due to expire August 23, 2002, be extended for three months and set to expire on November 23, 2002.

Please charge the extension fee of \$920.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Wesley L. Styrud
for
Scott D. Paul
Registration No. 42,984

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SDP:cac
Facsimile: (202) 756-8087
Date: November 25, 2002

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